

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:	)	
	)	
Wang-Jin Chen	)	Confirmation No.: 9153
	)	
Serial No.: 10/733,095	)	Group Art Unit: 2825
	)	
Filed: December 11, 2003	)	Examiner: Rossoshek, Yelena
	)	
For: I/O CIRCUIT PLACEMENT METHOD AND	)	TKHR Ref. 250606-1020
SEMICONDUCTIVE DEVICE	)	Top-Team ref. 0697-10333US
	)	
	)	
	)	

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Mail Stop – AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The FINAL Office Action mailed, May 16, 2006 has been carefully considered. In response thereto, Applicant respectfully requests consideration of the following remarks.

OK TO ENTER  
HE 08/28/2006